

03-24-2004



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TO THE HONORABLE DIRECTOR, U.S. PATENT AND TRADEMARK OFFICE. PLEASE RECORD THE ATTACHED ORIGINAL DOCUMENTS OR COPY THEREOF.

<p>1. Name of conveying parties:</p> <p>LEE, Ho 3-22-04</p> <p>Additional name(s) of conveying party(ies) attached?</p> <p style="text-align: right;"><input type="checkbox"/> Yes <input checked="" type="checkbox"/> No</p>	<p>2. Name and address of receiving party:</p> <p>Name: SAMSUNG ELECTRONICS CO., LTD.</p> <p>Address: 416, Maetan-dong, Yeongtong-gu, Suwon-si, Gyeonggi-do, Korea</p> <p>Additional name(s) of receiving party(ies) attached?</p> <p style="text-align: right;"><input type="checkbox"/> Yes <input checked="" type="checkbox"/> No</p>
<p>3. Nature of Conveyance:</p> <p><input checked="" type="checkbox"/> Assignment <input type="checkbox"/> Merger</p> <p><input type="checkbox"/> Security Agreement <input type="checkbox"/> Change of Name</p> <p><input type="checkbox"/> Other _____</p> <p>Execution Date: <u>March 8, 2004</u></p>	<div style="border: 1px solid black; padding: 5px; transform: rotate(90deg); transform-origin: right top;"> OFFICE OF RECORDS 2004 MAR 22 AM 10:35 FINANCE SECTION </div>
<p>4. Application number(s) or patent number(s):</p> <p>If this document is being filed together with a new application, the execution date of the application is: _____</p>	
<p>A. Patent Application No.(s) – <u>10/750,023</u></p> <p>CHEMICAL VAPOR DEPOSITION APPARATUS</p>	<p>B. Patent No.(s)</p>
<p style="text-align: center;">Additional numbers attached? <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No</p>	
<p>5. Name and address of party to whom correspondence concerning document should be mailed:</p> <p>Name: <u>David Heid</u></p> <p>Internal Address: <u>MACPHERSON, KWOK CHEN & HEID LLP</u></p> <p>Street Address: <u>1762 Technology Drive, Suite 226</u></p> <p>City <u>San Jose</u> State <u>CA</u> Zip <u>95110</u></p>	<p>6. Total number of applications and patents involved: <u>One (1)</u></p>
<p>7. Total fee (37 CFR 3.41): \$40.00</p> <p><input checked="" type="checkbox"/> Authorized to be charged to Deposit Account No. 50-2257.</p> <p><input checked="" type="checkbox"/> Charge Deposit Account No. 50-2257 for any additional fees required for this conveyance and credit Deposit Account No. 50-2257 any amounts overpaid</p>	
<p>03/23/2004 LMUELLER 00000101 502257 10750023 DO NOT USE THIS SPACE</p> <p>01 FC:8021 40.00 DA</p>	
<p>8. Statement and signature.</p> <p><i>To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.</i></p> <p style="text-align: center;"> <u>David W. Heid</u> 25,875 <u>3/12/04</u> Name of Person Signing Signature Date </p> <p style="text-align: right;">Total number of pages comprising cover sheet: <u>2</u></p>	

ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, I, **LEE, Ho** of Wolbong Daewoo Apt. 102-1503, Ssangyong-dong, Cheonan-city, Chungcheongnam-do, Korea, hereby sell, assign and transfer to **SAMSUNG ELECTRONICS CO., LTD.**, a corporation, having a place of business at 416, Maetan-dong, Yeongtong-gu, Suwon-si, Gyeonggi-do, Korea, its successors and assigns, the entire right, title and interest throughout the world in my invention in

CHEMICAL VAPOR DEPOSITION APPARATUS

for which I filed a United States Patent Application on December 31, 2003, which now has Application No. 10/750,023, and all patent applications and patents of every country for said invention, including divisions, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; I authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from us; I agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, their successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and I request that the United States Patent and Trademark Office issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Executed this 8th day of March, 2004.

LEE Ho

LEE, Ho

WITNESSED:

Signature

March 8, 2004

Date

KIM, DAE-SHIG

Type or print name of witness